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PALM INTRANET

Application Number Information

Application Number: 10/584729

Assignments

Filing or 371(c) Date: 00/00/0000 eDan

Effective Date: 06/23/2006

Application Received: 06/23/2006

Patent Number:

Issue Date: 00/00/0000

Date of Abandonment: 00/00/0000

Attorney Docket Number: 0756-7709

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Confirmation Number: 6076

Title of Invention: LASER IRRADIATION METHOD, LASER IRRADIATION APPARATUS

Examiner Number: 00000 /

Group Art Unit: 2812

Class/Subclass: 438/151.000

Lost Case: NO

Interference Number: Unmatched Petition: NO L&R Code: Secrecy Code:1

Third Level Review: NO

Secrecy Order: NO

IFW Madras

Oral Hearing: NO

AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Bar Code PALM Location Location Date Charge to Loc Charge	ge to Name Employee Name Location
Appln Contents Petition info Atty/Agent Info C	ontinuity/Reexam Foreign Data
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